

PATENT ASSIGNMENT

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SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT
CONVEYING PARTY DATA	
Name	Execution Date
Harald Herchen	10/24/2007
RECEIVING PARTY DATA	
Name:	Sokudo Co., Ltd.
Street Address:	K-I Shijo Building, 88 Kankoboko-cho
Internal Address:	Shijodori-Muromachi-Higashiiru
City:	Shimogyo-ku, Kyoto
State/Country:	JAPAN
Postal Code:	600-8009
PROPERTY NUMBERS Total: 1	
Property Type	Number
Application Number:	11924433
CORRESPONDENCE DATA	
Fax Number:	(415)576-0300
<i>Correspondence will be sent via US Mail when the fax attempt is unsuccessful.</i>	
Phone:	206-467-9600
Email:	jms@townsend.com
Correspondent Name:	Jennifer Smolen
Address Line 1:	Townsend and Townsend and Crew LLP
Address Line 2:	Two Embarcadero Center, 8th Floor
Address Line 4:	San Francisco, CALIFORNIA 94111
ATTORNEY DOCKET NUMBER:	026531-009300US
NAME OF SUBMITTER:	Jennifer M. Smolen
Total Attachments: 1 source=26531_93US_Assign#page1.tif	

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ASSIGNMENT OF PATENT APPLICATION

SOLE

WHEREAS, Harald Herchen of 927 Lundy Lane, Los Altos, CA 94024, hereinafter referred to as "Assignor," is the inventor of the invention described and set forth in the below-identified application for United States Letters Patent:

Title of Invention: METHOD AND APPARATUS FOR DETECTING
 SUBSTRATE TEMPERATURE IN A TRACK
 LITHOGRAPHY TOOL

Date(s) of execution of Declaration:

Filing Date: October 25, 2007

Application No.: 11/924,433 ; and

WHEREAS, Sokudo Co., Ltd., located at K-I Shijo Building, 88 Kankoboko-cho, Shijodori-Muromachi-Higashiiru, Shimogyo-ku, Kyoto 600-8009, JAPAN, hereinafter referred to as "ASSIGNEE," is desirous of acquiring an interest in the invention and application and in any U.S. Letters Patent and Registrations which may be granted on the same;

For good and valuable consideration, receipt of which is hereby acknowledged by Assignor, Assignor has assigned, and by these presents does assign to Assignee all right, title and interest in and to the invention and application and to all foreign counterparts (including patent, utility model and industrial designs), and in and to any Letters Patent and Registrations which may hereafter be granted on any patent application claiming priority from the same in the United States and all countries throughout the world, and to claim the priority from the application as provided by the Paris Convention. The right, title and interest is to be held and enjoyed by Assignee and Assignee's successors and assigns as fully and exclusively as it would have been held and enjoyed by Assignor had this Assignment not been made, for the full term of any Letters Patent and Registrations which may be granted thereon, or of any division, renewal, continuation in whole or in part, substitution, conversion, reissue, prolongation or extension thereof.

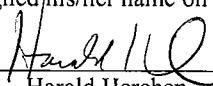
Assignor further agrees that Assignor will, without charge to Assignee, but at Assignee's expense, (a) cooperate with Assignee in the prosecution of U.S. Patent applications and foreign counterparts on the invention and any improvements, (b) execute, verify, acknowledge and deliver all such further papers, including applications and instruments of transfer, and (c) perform such other acts as Assignee lawfully may request to obtain or maintain Letters Patent and Registrations for the invention and improvements in any and all countries, and to vest title thereto in Assignee, or Assignee's successors and assigns.

Assignor hereby authorizes and requests Townsend and Townsend and Crew LLP, Two Embarcadero Center, Eighth Floor, San Francisco, CA 94111-3834, to insert herein above the application number and filing date of said application when known.

IN TESTIMONY WHEREOF, Assignor has signed his/her name on the date indicated.

Dated:

Oct 24, 07


Harald Herchen